

Article

Supplementary Material: Synthesis of High-Performance Photonic Crystal Film for SERS Applications via Drop-Coating Method

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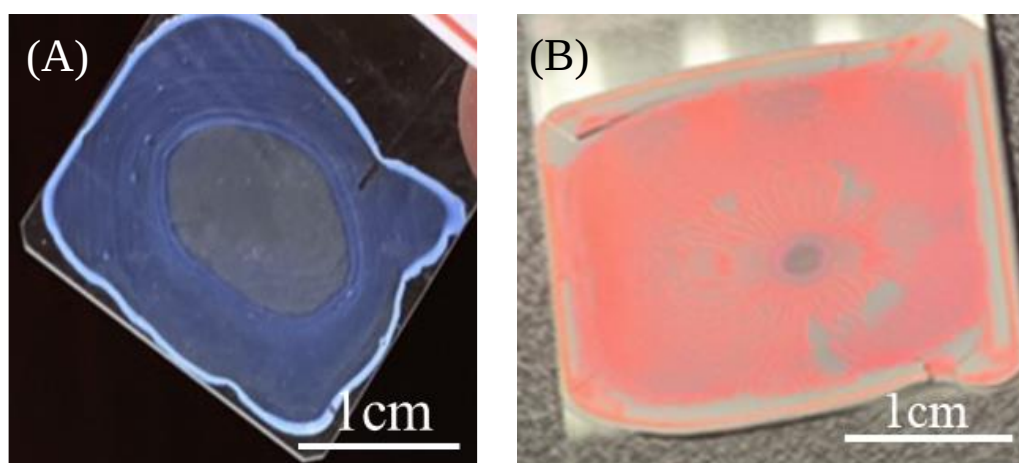


Figure 1. Photos of PC films prepared by silica with particle size of (A) 200 nm and (B) 356 nm.



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